IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Aharon J. AGRANAT.et al

Serial No.:

US National Phase of

PCT/IL2004/000726

Filed:

Herewith

For:

Stable Dielectric Gratings Implemented By

Composition Striations In Paraelectric Crystals

Examiner:

Not Yet Assigned

Mail Stop Amendment **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450 IAP2D Rec'd PCT/PTO 30 JAN 2006

Group Art Unit: Not Yet Assigned

Attorney

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Docket: 31316

INFORMATION DISCLOSURE STATEMENT

Sir:

Enclosed is a PTO Form 1449 which lists citations which may be material to the patentability and examination of the above identified application. Also enclosed are copies of the references cited. These are submitted in compliance with the duty of disclosure defined in 37 CFR 1.56. The Examiner is requested to make these citations of official record in this application.

This Information Disclosure Statement under 37 CFR 1.56 is not to be construed as a representation that a search has been made, that additional matter which is material to the examination of this application does not exist, or that any or more of these citations constitutes prior art.

Respectfully submitted,

Martin D. Moynihan

Registration No. 40,338

Dated: January 30, 2006

PTO/SB/08a (08-03)

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